

MAR 10 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.009-US)In the Application of: **Lutz et al.**Serial No: **10/777,326**Filed: **February 12, 2004**Title: **Integrated Getter Area for Wafer Level
Encapsulated Microelectromechanical
Systems**) Group Art Unit: **2813**) Examiner: **David S. Blum**

I hereby certify that this correspondence
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Date

Neil Sternberg

(name of person signing certificate)



Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND REPLY OF MARCH 10, 2005

Dear Sir:

Kindly amend the application as follows: